

**REPLY UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 2800**

Attorney's Docket No.: 51876.P507

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application for:

**Sung-Kwon Lee, et al.**

Serial No.: 10/750,001

Filed: December 30, 2003

For: **METHOD FOR FABRICATING  
SEMICONDUCTOR DEVICE**

Examiner: Quovaunda Jefferson

Art Group: 2823

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Ma'am:

In response to the Final Office Action dated January 26, 2007, please amend and the above-captioned application as set forth below.

**Amendments to the Claims** are reflected in the Listing of Claims and begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.